

IN THE U.S. PATENT AND TRADEMARK OFFICE
I N F O R M A T I O N S H E E T

jc011 U.S. PRO
10/024307
12/21/01

Applicant: TAKASHIMA, Masayuki
 UEDA, Kazumasa

Application No.:

Filed: December 21, 2001

For: POLISHING PAD, POLISHING APPARATUS AND POLISHING METHOD
 USING THE SAME

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
JAPAN	12/28/00	2000-399684

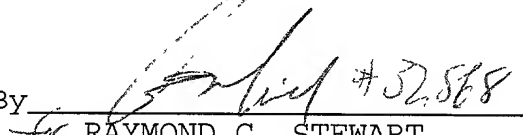
Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP
 P. O. Box 747
 Falls Church, Virginia 22040-0747
 (703) 205-8000

The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

 #32,568

RAYMOND C. STEWART

Reg. No. 21,066

P. O. Box 747

Falls Church, VA 22040-0747

/sll

(703) 205-8000